## Applicant(s)/Patent Under Application/Control No. Reexamination 10/791,832 FUJIMORI ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 2871 David Y. Chung **U.S. PATENT DOCUMENTS** Document Number Date Classification Name Country Code-Number-Kind Code MM-YYYY 349/129 05-2000 US-6,067,141 Yamada et al. Α 349/156 11-1999 Tamai et al. В US-5,995,191 349/130 09-2004 Ogishima et al. С US-6,788,375 US-D US-Ε F US-US-G Н US-US-1 US-J US-Κ US-L US-М FOREIGN PATENT DOCUMENTS Document Number Date Classification Name Country Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) W

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